



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 15, 2026

IGI Report Number **LG746518338**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.30 - 7.36 X 4.56 MM**

GRADING RESULTS

Carat Weight **1.51 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

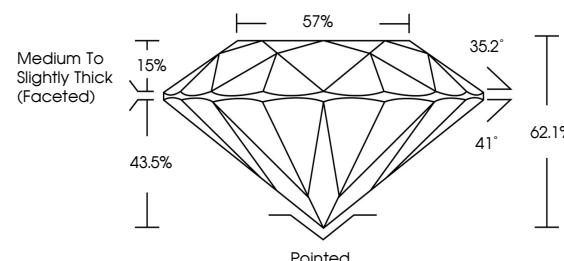
IGI **LG746518338**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

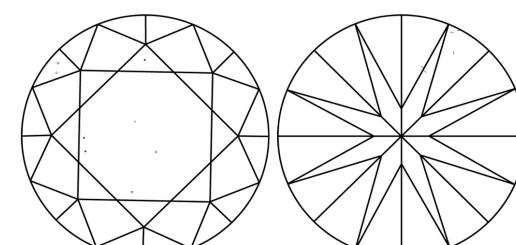
Type Ila

LG746518338
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

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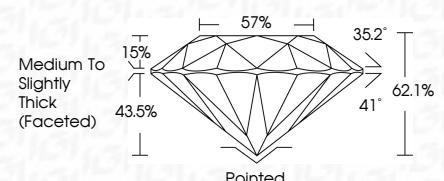
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Sample Image Used



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Fluorescence **NONE**

Inscription(s) **IGI LG746518338**

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January 15, 2026
IGI Report No LG746518338
ROUND BRILLIANT
7.30 - 7.36 X 4.56 MM
1.51 CARAT
E
VS 2
IDEAL
G2 1%
67%
Medium To Slightly Thick (Faceted)
Pointed
Excellent
Excellent
None
Fluorescence
Inscription(s)
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila